

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L15	9	((("6904191") or ("6828887") or ("6510275") or ("6658179") or ("6580858") or ("6379989") or ("6567448") or ("6054335") or ("6177800"))).PN.	US-PGPUB; USPAT	OR	OFF	2005/06/08 10:34
L17	210	(thermal near2 actuator) same width	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/08 10:35

L18	113	(US-20010017358-\$ or US-20010050232-\$ or US-20020011758-\$ or US-20020164123-\$ or US-20020174891-\$ or US-20020190603-\$ or US-20030011254-\$ or US-20030029705-\$ or US-20030053231-\$ or US-20030086641-\$ or US-20030098612-\$ or US-20030121260-\$ or US-20030132090-\$ or US-20030132822-\$ or US-20030160539-\$ or US-20030210115-\$ or US-20040027029-\$ or US-20040032000-\$ or US-20040085608-\$ or US-20040114856-\$ or US-20040118481-\$ or US-20040126080-\$ or US-20040126081-\$ or US-20040184709-\$ or US-20040184710-\$ or US-20040184720-\$).did. or (US-20040184760-\$ or US-20040189142-\$ or US-20040196522-\$ or US-20050011191-\$ or US-20050031252-\$ or US-20050031253-\$ or US-20050031288-\$).did. or (US-4887100-\$ or US-5024500-\$ or US-5364497-\$ or US-5583290-\$ or US-5862003-\$ or US-5870518-\$ or US-5909078-\$ or US-5955817-\$ or US-5962949-\$ or US-5994816-\$ or US-5998906-\$ or US-6023121-\$ or US-6032532-\$ or US-6114794-\$ or US-6124663-\$ or US-6133670-\$ or US-6134207-\$ or US-6137206-\$ or US-6164837-\$ or US-6210046-\$ or US-6218762-\$ or US-6236139-\$ or US-6253011-\$ or US-6255757-\$ or US-6262512-\$ or US-6275320-\$).did. or (US-6291922-\$ or US-6303885-\$ or US-6308631-\$ or US-6310419-\$ or US-6324748-\$ or US-6333583-\$ or US-6338249-\$ or US-6351580-\$ or US-6360033-\$ or US-6360539-\$ or US-6363183-\$ or US-6367251-\$ or US-6367252-\$ or US-6386507-\$ or US-6388359-\$ or US-6404969-\$ or US-6407478-\$ or US-6422011-\$ or US-6428173-\$ or US-6487330-\$ or US-6504868-\$ or US-6590313-\$ or US-6596147-\$ or US-6628039-\$ or US-6658170-\$ or US-6661067-\$	US-PGPUB; USPAT; EPO; DERWENT	OR	ON	2005/06/08 10:35
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L19	198	L17 not L18	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/08 10:35
L20	1	2005-210748.NRAN.	DERWENT	OR	ON	2005/06/08 10:41
L21	1	2005-210744.NRAN.	DERWENT	OR	ON	2005/06/08 10:41
L22	1	2005-210744.NRAN.	DERWENT	OR	ON	2005/06/08 10:42
L23	103	(thermal with actuator) and (beam with spacing)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/08 10:43

L24	103	(US-20030086641-\$ or US-20040032000-\$ or US-20010050232-\$ or US-20020011758-\$ or US-20020164123-\$ or US-20030053231-\$ or US-20030132822-\$ or US-20030132090-\$ or US-20030210115-\$ or US-20040027029-\$ or US-20040114856-\$ or US-20040118481-\$ or US-20040184760-\$ or US-20040184720-\$ or US-20040184710-\$ or US-20040184709-\$ or US-20050031288-\$ or US-20050031253-\$ or US-20050031252-\$ or US-20030121260-\$ or US-20010017358-\$ or US-20020190603-\$ or US-20030011254-\$ or US-20030160539-\$ or US-20040085608-\$ or US-20040126081-\$).did. or (US-20040126080-\$ or US-20040189142-\$ or US-20040196522-\$ or US-20050011191-\$ or US-20020174891-\$ or US-20030029705-\$ or US-20030098612-\$).did. or (US-5909078-\$ or US-5994816-\$ or US-6023121-\$ or US-6114794-\$ or US-6255757-\$ or US-6324748-\$ or US-6360539-\$ or US-6828887-\$ or US-5024500-\$ or US-6303885-\$ or US-6487330-\$ or US-5998906-\$ or US-6124663-\$ or US-6134207-\$ or US-6218762-\$ or US-6236139-\$ or US-6275320-\$ or US-6338249-\$ or US-6351580-\$ or US-6360033-\$ or US-6363183-\$ or US-6367252-\$ or US-5955817-\$ or US-5962949-\$ or US-6367251-\$ or US-6388359-\$).did. or (US-6404969-\$ or US-6428173-\$ or US-6504968-\$ or US-6590313-\$ or US-6596147-\$ or US-6658179-\$ or US-6754243-\$ or US-6771158-\$ or US-6807356-\$ or US-6836584-\$ or US-6853765-\$ or US-4887100-\$ or US-5364497-\$ or US-5583290-\$ or US-6032532-\$ or US-5870518-\$ or US-6164837-\$ or US-6310419-\$ or US-6386507-\$ or US-6422011-\$ or US-6673378-\$ or US-6708492-\$ or US-6133670-\$ or US-6137206-\$ or US-5862003-\$ or US-6201022-\$)	US-PGPUB; USPAT; EPO; DERWENT	OR	ON	2005/06/08 10:43
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L25	21	L23 and L24	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/08 10:43
L26	3	(thermal with actuator) and (beam with resistance with width)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/08 10:43
L27	394	(beam with resistance with width)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/08 10:43
L28	360	(optical with switch\$2) and substrate and (beam or waveguide or fiber) and (thermal with actuator)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/08 10:43
L29	1176	(substrate same (beam or waveguide or fiber)) and (thermal with actuator)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/08 10:43
L30	869	L29 not L28	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/06/08 10:43
S1	15	((("5706041") or ("5851412") or ("6362512") or ("6379989") or ("6002507") or ("6014240") or ("5909078") or ("5994816") or ("6023121") or ("6114794") or ("6255757") or ("6324748") or ("6360539") or ("20030134445") or ("20030086641"))).PN.	US-PGPUB; USPAT	OR	OFF	2005/03/07 09:21
S2	1	("6658179").PN.	US-PGPUB; USPAT	OR	OFF	2005/03/07 09:40
S3	9	((("6828171") or ("6467879") or ("6479311") or ("6479315") or ("6506620") or ("6580858") or ("6510275") or ("6828887") or ("6661070"))).PN.	US-PGPUB; USPAT	OR	OFF	2005/03/07 10:41

S4	11	((("5024500") or ("6487330") or ("6842558") or ("6201629") or ("5969848") or ("6033670") or ("5502781") or ("6072924") or ("6303885") or ("6526198") or ("20040032000")).PN.	US-PGPUB; USPAT	OR	OFF	2005/03/07 10:42
S5	333	(optical with switch\$2) and substrate and (beam or waveguide or fiber) and (thermal with actuator)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/07 11:44
S6	6	("5867302" "5955817" "5962949" "5994816" "6023121" "6114794").PN. OR ("6367252").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/03/07 10:57
S7	1	2002-548530.NRAN.	DERWENT	OR	ON	2005/03/07 11:03
S8	0	("2004/0184760").URPN.	USPAT	OR	ON	2005/03/07 11:36
S9	0	("2004/0118481").URPN.	USPAT	OR	ON	2005/03/07 11:37
S10	1	("2004/0114856").URPN.	USPAT	OR	ON	2005/03/07 11:37
S11	0	("2004/0184720").URPN.	USPAT	OR	ON	2005/03/07 11:37
S12	0	("2004/0184710").URPN.	USPAT	OR	ON	2005/03/07 11:37
S13	0	("2004/0184709").URPN.	USPAT	OR	ON	2005/03/07 11:37
S14	0	("6828887").URPN.	USPAT	OR	ON	2005/03/07 11:39
S15	0	("6853765").URPN.	USPAT	OR	ON	2005/03/07 11:40
S16	3	("5909078" "6168395" "6303885").PN. OR ("6828887").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/03/07 11:41
S17	6	("20020102061" "4946236" "5175776" "5446811" "6360036" "6388359").PN. OR ("6853765").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/03/07 11:41
S18	0	("2005/0031288").URPN.	USPAT	OR	ON	2005/03/07 11:43
S19	0	("2005/0031253").URPN.	USPAT	OR	ON	2005/03/07 11:43
S20	0	("2005/0031252").URPN.	USPAT	OR	ON	2005/03/07 11:43
S21	1461	substrate and (beam or waveguide or fiber) and (thermal with actuator)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/07 17:18
S22	1099	(substrate same (beam or waveguide or fiber)) and (thermal with actuator)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/07 16:08

S23	812	S22 not S5	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/07 11:45
S24	19	("4624741" "4893509" "5130276").PN. OR ("5364497"). URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/03/07 12:05
S25	1	1997-169577.NRAN.	DERWENT	OR	ON	2005/03/07 16:00
S26	35	("3836225" "4688885" "5080458" "5181214" "5214727" "5457765" "5483608" "5553182" "5602955" "5606635" "5699463").PN. OR ("5870518"). URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/03/07 16:02
S27	70	(substrate same (beam or waveguide or fiber)) and (thermal with actuator).ti.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/07 16:09
S28	333	(optical with switch\$2) and substrate and (beam or waveguide or fiber) and (thermal with actuator)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/07 16:09
S29	57	S27 not S28	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/07 16:09

S30	75	("1258368" "1658669" "2466703" "3213318" "3280550" "3304446" "3609593" "4806815" "5179499" "5180940" "5184269" "5191251" "5261747" "5296775" "5309056" "5355712" "5367584" "5441343" "5467068" "5475318" "5483799" "5536988" "5558304" "5600174" "5602955" "5606635" "5629665" "5644177" "5659285" "5722989" "5796152" "5813441" "5862003" "5881198" "5903078" "5909078").PN. OR ("6137206").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/03/07 16:14
S31	7	("5214735" "5677975" "5835652" "6085014" "6249636" "6374022" "6539161").PN. OR ("6661962"). URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/03/07 16:42
S32	1462	substrate and (beam or waveguide or fiber) and (thermal with actuator)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/07 17:19
S33	1100	(substrate same (beam or waveguide or fiber)) and (thermal with actuator)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/08 08:15
S34	813	S33 not S28	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/07 17:19
S35	622	S32 not (S34 or (silverbrook.in.))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/07 17:19

S36	104	(US-20030086641-\$ or US-20040032000-\$ or US-20010050232-\$ or US-20020011758-\$ or US-20020164123-\$ or US-20030053231-\$ or US-20030132822-\$ or US-20030132090-\$ or US-20030210115-\$ or US-20040027029-\$ or US-20040114856-\$ or US-20040118481-\$ or US-20040184760-\$ or US-20040184720-\$ or US-20040184710-\$ or US-20040184709-\$ or US-20050031288-\$ or US-20050031253-\$ or US-20050031252-\$ or US-20030121260-\$ or US-20010017358-\$ or US-20020190603-\$ or US-20030011254-\$ or US-20030160539-\$ or US-20040085608-\$ or US-20040126081-\$).did. or (US-20040126080-\$ or US-20040189142-\$ or US-20040196522-\$ or US-20050011191-\$).did. or (US-5909078-\$ or US-5994816-\$ or US-6023121-\$ or US-6114794-\$ or US-6255757-\$ or US-6324748-\$ or US-6360539-\$ or US-6828887-\$ or US-5024500-\$ or US-6303885-\$ or US-6487330-\$ or US-5998906-\$ or US-6124663-\$ or US-6134207-\$ or US-6218762-\$ or US-6236139-\$ or US-6275320-\$ or US-6338249-\$ or US-6351580-\$ or US-6360033-\$ or US-6363183-\$ or US-6367252-\$ or US-5955817-\$ or US-5962949-\$ or US-6367251-\$ or US-6388359-\$).did. or (US-6404969-\$ or US-6428173-\$ or US-6504968-\$ or US-6590313-\$ or US-6596147-\$ or US-6658179-\$ or US-6754243-\$ or US-6771158-\$ or US-6807356-\$ or US-6836584-\$ or US-6853765-\$ or US-4887100-\$ or US-5364497-\$ or US-5583290-\$ or US-6032532-\$ or US-5870518-\$ or US-6164837-\$ or US-6310419-\$ or US-6386507-\$ or US-6422011-\$ or US-6675578-\$ or US-6708492-\$ or US-6133670-\$ or US-6137206-\$ or US-5862003-\$ or US-6291922-\$ or US-6407478-\$).did. or (US-6628039-\$ or US-6210046-\$ or US-6252011-\$ or US-6262512-\$	US-PGPUB; USPAT; EPO; DERWENT	OR	ON	2005/03/07 17:19
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S37	288	S35 not (S36 or S28)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/07 17:20
S38	2	("2003/0029705").URPN.	USPAT	OR	ON	2005/03/07 17:28
S39	12	("20010008357" "4806815" "5796152" "5909078" "5994816" "6211598" "6236139" "6255757" "6291922" "6367251" "6386507" "6590313").PN. OR ("6734597").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/03/07 17:31
S40	2	("6310419" "6407478").PN. OR ("6753582").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/03/07 17:32
S41	6	("20020114058" "5909078" "5963367" "6467761" "6672795" "6679055").PN. OR ("6806991").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/03/07 17:33
S42	0	(substrate same (beam or waveguide or fiber)) and (ladder with thermal with actuator)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/08 08:15
S43	12	("20010008357" "4806815" "5796152" "5909078" "5994816" "6211598" "6236139" "6255757" "6291922" "6367251" "6386507" "6590313").PN. OR ("6734597").URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2005/03/08 08:35
S44	0	("WO199098").PN.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/03/08 11:32
S45	1	"WO01/99098"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/08 08:38
S46	0	"01/99098"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/08 08:38

S47	0	"\$01/99098"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/08 08:38
S48	387	(beam with resistance with width)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/08 14:08
S49	3	(thermal with actuator) and (beam with resistance with width)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/08 14:11
S50	99	(thermal with actuator) and (beam with spacing)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/08 14:11

S51	113	(US-20030086641-\$ or US-20040032000-\$ or US-20010050232-\$ or US-20020011758-\$ or US-20020164123-\$ or US-20030053231-\$ or US-20030132822-\$ or US-20030132090-\$ or US-20030210115-\$ or US-20040027029-\$ or US-20040114856-\$ or US-20040118481-\$ or US-20040184760-\$ or US-20040184720-\$ or US-20040184710-\$ or US-20040184709-\$ or US-20050031288-\$ or US-20050031253-\$ or US-20050031252-\$ or US-20030121260-\$ or US-20010017358-\$ or US-20020190603-\$ or US-20030011254-\$ or US-20030160539-\$ or US-20040085608-\$ or US-20040126081-\$).did. or (US-20040126080-\$ or US-20040189142-\$ or US-20040196522-\$ or US-20050011191-\$ or US-20020174891-\$ or US-20030029705-\$ or US-20030098612-\$).did. or (US-5909078-\$ or US-5994816-\$ or US-6023121-\$ or US-6114794-\$ or US-6255757-\$ or US-6324748-\$ or US-6360539-\$ or US-6828887-\$ or US-5024500-\$ or US-6303885-\$ or US-6487330-\$ or US-5998906-\$ or US-6124663-\$ or US-6134207-\$ or US-6218762-\$ or US-6236139-\$ or US-6275320-\$ or US-6338249-\$ or US-6351580-\$ or US-6360033-\$ or US-6363183-\$ or US-6367252-\$ or US-5955817-\$ or US-5962949-\$ or US-6367251-\$ or US-6388359-\$).did. or (US-6404969-\$ or US-6428173-\$ or US-6504968-\$ or US-6590313-\$ or US-6596147-\$ or US-6658179-\$ or US-6754243-\$ or US-6771158-\$ or US-6807356-\$ or US-6836584-\$ or US-6853765-\$ or US-4887100-\$ or US-5364497-\$ or US-5583290-\$ or US-6032532-\$ or US-5870518-\$ or US-6164837-\$ or US-6310419-\$ or US-6386507-\$ or US-6422011-\$ or US-6675578-\$ or US-6708492-\$ or US-6133670-\$ or US-6137206-\$ or US-5967002-\$ or US-6701072-\$	US-PGPUB; USPAT; EPO; DERWENT	OR	ON	2005/03/08 14:12
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S52	24	S50 and S51	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/08 14:12
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Day : Wednesday

Date: 6/8/2005

Time: 09:49:51

PALM INTRANET

Inventor Name Search Result

Your Search was:

Last Name = KUBBY

First Name = JOEL

Application#	Patent#	Status	Date Filed	Title	Inventor Name 50
<u>60421933</u>	Not Issued	159	10/28/2002	STRUCTURE AND METHOD FOR A MICROELECTROMECHANIC CYLINDRICAL REFLECTIVE DIFFRACTION GRATING SPECTROPHOTOMETER	KUBBY, JOEL A.
<u>60325282</u>	Not Issued	159	09/27/2001	SPACING COMPENSATING ELECTROSTATIC VOLTMETER	KUBBY, JOEL A.
<u>11092835</u>	Not Issued	020	03/30/2005	DISTRIBUTED BRAGG REFLECTOR SYSTEMS AND METHODS	KUBBY, JOEL A.
<u>11092635</u>	Not Issued	020	03/30/2005	TWO-DIMENSIONAL SPECTRAL CAMERAS AND METHODS FOR CAPTURING SPECTRAL INFORMATION USING TWO- DIMENSIONAL SPECTRAL CAMERAS	KUBBY, JOEL A.
<u>11016952</u>	Not Issued	020	12/20/2004	FULL WIDTH ARRAY MECHANICALLY TUNABLE SPECTROPHOTOMETER	KUBBY, JOEL A.
<u>11013689</u>	Not Issued	020	12/17/2004	BINDING SYSTEMS USING INK JET PRINTING TECHNOLOGY	KUBBY, JOEL
<u>11010769</u>	Not Issued	030	12/13/2004	CANTILEVER BEAM MEMS VARIABLE OPTICAL ATTENUATOR	KUBBY, JOEL A.
<u>10995965</u>	Not Issued	030	11/23/2004	MICROFABRICATION PROCESS FOR CONTROL OF WAVEGUIDE GAP SIZE	KUBBY, JOEL A.
<u>10918093</u>	Not Issued	030	08/13/2004	BEAM SWITCH STRUCTURES AND METHODS	KUBBY, JOEL A.
<u>10914531</u>	Not Issued	020	08/09/2004	MICROMECHANICAL DISPENSING DEVICE AND A DISPENSING SYSTEM INCLUDING	KUBBY, JOEL A.

				THE SAME	
<u>10879094</u>	Not Issued	020	06/30/2004	OPTICAL SHUTTLE SYSTEM AND METHOD USED IN AN OPTICAL SWITCH	KUBBY, JOEL A.
<u>10878834</u>	Not Issued	030	06/28/2004	WAVEGUIDE STRUCTURES AND METHODS	KUBBY, JOEL A.
<u>10873125</u>	Not Issued	030	06/23/2004	ELECTROSTATIC ACTUATOR WITH SEGMENTED ELECTRODE	KUBBY, JOEL A.
<u>10828411</u>	Not Issued	020	04/20/2004	VIDEO GAME SYSTEM INCLUDING A MICROMECHANICAL DISPENSING DEVICE	KUBBY, JOEL A.
<u>10827922</u>	Not Issued	020	04/20/2004	ENVIRONMENTAL SYSTEM INCLUDING A MICROMECHANICAL DISPENSING DEVICE	KUBBY, JOEL A.
<u>10827866</u>	Not Issued	160	04/20/2004	DISPENSING SYSTEM INCLUDING A MICROMECHANICAL DISPENSING DEVICE	KUBBY, JOEL A.
<u>10772693</u>	Not Issued	071	02/05/2004	THERMAL ACTUATOR WITH OFFSET BEAM SEGMENT NEUTRAL AXES AND AN OPTICAL WAVEGUIDE SWITCH INCLUDING THE SAME	KUBBY, JOEL A.
<u>10772564</u>	Not Issued	071	02/05/2004	THERMAL ACTUATOR AND AN OPTICAL WAVEGUIDE SWITCH INCLUDING THE SAME	KUBBY, JOEL A.
<u>10760846</u>	Not Issued	030	01/20/2004	LOW LOSS SILICON WAVEGUIDE AND METHOD OF FABRICATION THEREOF	KUBBY, JOEL A.
<u>10732724</u>	Not Issued	020	12/10/2003	DEVICE AND SYSTEM FOR DISPENSING FLUIDS INTO THE ATMOSPHERE	KUBBY, JOEL A.
<u>10727191</u>	Not Issued	041	12/03/2003	BISTABLE MICROELECTROMECHANICAL SYSTEM BASED STRUCTURES, SYSTEMS AND METHODS	KUBBY, JOEL A.
<u>10721849</u>	Not Issued	071	11/25/2003	MONOLITHIC RECONFIGURABLE OPTICAL MULTIPLEXER SYSTEMS AND METHODS	KUBBY, JOEL A.
<u>10721724</u>	Not Issued	030	11/24/2003	ELECTRICAL STIMULI OF MEMS DEVICES	KUBBY, JOEL A.
<u>10712203</u>	Not Issued	092	11/12/2003	MEMS OPTICAL LATCHING SWITCH	KUBBY, JOEL A.
<u>10712200</u>	Not	041	11/12/2003	MEMS WAVEGUIDE SHUTTLE	KUBBY, JOEL

	Issued			OPTICAL LATCHING SWITCH	A.
<u>10703382</u>	<u>6904191</u>	150	11/07/2003	MXN CANTILEVER BEAM OPTICAL WAVEGUIDE SWITCH	KUBBY, JOEL A.
<u>10672207</u>	Not Issued	092	09/26/2003	STRUCTURE AND METHOD FOR A MICROELECTROMECHANIC CYLINDRICAL REFLECTIVE DIFFRACTION GRATING SPECTROPHOTOMETER	KUBBY, JOEL A.
<u>10634941</u>	Not Issued	071	08/05/2003	THERMAL ACTUATOR AND AN OPTICAL WAVEGUIDE SWITCH INCLUDING THE SAME	KUBBY, JOEL A.
<u>10225555</u>	<u>6806717</u>	150	08/21/2002	SPACING COMPENSATING ELECTROSTATIC VOLTMETER	KUBBY, JOEL A.
<u>10193804</u>	<u>6661070</u>	150	07/11/2002	MICROMECHANICAL AND MICROOPTOMECHANICAL STRUCTURES WITH SINGLE CRYSTAL SILICON EXPOSURE STEP	KUBBY, JOEL A.
<u>10192087</u>	Not Issued	161	07/09/2002	MICROMECHANICAL AND MICROOPTOMECHANICAL STRUCTURES WITH BACKSIDE METALIZATION	KUBBY, JOEL A.
<u>10063762</u>	<u>6828887</u>	150	05/10/2002	BISTABLE MICROELECTROMECHANICAL SYSTEM BASED STRUCTURES, SYSTEMS AND METHODS	KUBBY, JOEL A.
<u>10022917</u>	<u>RE38437</u>	150	12/20/2001	METHOD AND APPARATUS FOR AN INTEGRATED LASER BEAM SCANNER USING A CARRIER SUBSTRATE	KUBBY, JOEL A.
<u>10014563</u>	Not Issued	094	12/14/2001	METHOD AND APPARATUS FOR AN INTEGRATED LASER BEAM SCANNER	KUBBY, JOEL A.
<u>09986399</u>	<u>6510275</u>	150	11/08/2001	MICRO- OPTOELECTROMECHANICAL SYSTEM BASED DEVICE WITH ALIGNED STRUCTURES AND METHOD FOR FABRICATING SAME	KUBBY, JOEL A.
<u>09986395</u>	<u>6658179</u>	150	11/08/2001	MONOLITHIC RECONFIGURABLE OPTICAL MULTIPLEXER SYSTEMS AND METHODS	KUBBY, JOEL A.
<u>09986107</u>	Not Issued	161	11/07/2001	MEMBRANE STRUCTURES FOR MICRO-DEVICES, MICRO- DEVICES INCLUDING SAME AND METHODS FOR MAKING SAME	KUBBY, JOEL A.

<u>09863637</u>	<u>6662448</u>	150	05/23/2001	METHOD OF FABRICATING A MICRO-ELECTRO-MECHANICAL FLUID EJECTOR	KUBBY, JOEL A.
<u>09844574</u>	<u>6580858</u>	150	04/30/2001	MICRO-OPTO-ELECTRO-MECHANICAL SYSTEM (MOEMS)	KUBBY, JOEL A.
<u>09724515</u>	<u>6506620</u>	150	11/27/2000	PROCESS FOR MANUFACTURING MICROMECHANICAL AND MICROOPTOMECHANICAL STRUCTURES WITH BACKSIDE METALIZATION	KUBBY, JOEL A.
<u>09724514</u>	<u>6479315</u>	150	11/27/2000	PROCESS FOR MANUFACTURING MICROMECHANICAL AND MICROOPTOMECHANICAL STRUCTURES WITH SINGLE CRYSTAL SILICON EXPOSURE STEP	KUBBY, JOEL A.
<u>09724506</u>	<u>6479311</u>	150	11/27/2000	PROCESS FOR MANUFACTURING MICROMECHANICAL AND MICROOPTOMECHANICAL STRUCTURES WITH PRE-APPLIED PATTERNING	KUBBY, JOEL A.
<u>09709096</u>	<u>6473361</u>	150	11/10/2000	ELECTROMECHANICAL MEMORY CELL	KUBBY, JOEL A.
<u>09687096</u>	<u>6467879</u>	150	10/16/2000	METHOD AND APPARATUS FOR PREVENTING DEGRADATION OF ELECTROSTATICALLY ACTUATED DEVICES	KUBBY, JOEL A.
<u>09683533</u>	<u>6828171</u>	150	01/16/2002	SYSTEMS AND METHODS FOR THERMAL ISOLATION OF A SILICON STRUCTURE	KUBBY, JOEL A.
<u>09535007</u>	<u>6384918</u>	150	03/23/2000	SPECTROPHOTOMETER FOR COLOR PRINTER COLOR CONTROL WITH DISPLACEMENT INSENSITIVE OPTICS	KUBBY, JOEL A.
<u>09467482</u>	<u>6399405</u>	150	12/20/1999	PROCESS FOR CONSTRUCTING A SPECTROPHOTOMETER	KUBBY, JOEL A.
<u>09467185</u>	<u>6249346</u>	150	12/20/1999	MONOLITHIC SPECTROPHOTOMETER	KUBBY, JOEL A.
<u>09467184</u>	<u>6608679</u>	150	12/20/1999	SPECTROPHOTOMETRIC ANALYSIS OF INPUT LIGHT	KUBBY, JOEL A.

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Application#	Patent#	Status	Date Filed	Title	Inventor Name 50
60456087	Not Issued	159	03/19/2003	MEMS WAVEGUIDE SHUTTLE OPTICAL LATCHING SWITCH	KUBBY, JOEL H.
60456086	Not Issued	159	03/19/2003	MXN CANTILEVER BEAM OPTICAL WAVEGUIDE SWITCH	KUBBY, JOEL H.
60456063	Not Issued	159	03/19/2003	MEMS OPTICAL LATCHING SWITCH	KUBBY, JOEL H.
60113777	Not Issued	159	12/23/1998	SILICON ON INSULATOR SURFACE MICROMACHINING PROCESS	KUBBY, JOEL A.
60113240	Not Issued	159	12/21/1998	MONOLITHIC SPECTROPHOTOMETER	KUBBY, JOEL A.
60104356	Not Issued	159	10/15/1998	MICRO-ELECTRO-MECHANICAL INK JET DROP EJECTOR	KUBBY, JOEL A.
60069674	Not Issued	159	12/12/1997	MONOLITHIC SCANNING VCSELS USING III-V MICROMACHINING	KUBBY, JOEL A.
11113124	Not Issued	020	04/25/2005	RFID ACTIVATED PAPERCLIP TAG	KUBBY, JOEL A.
09469892	6295130	150	12/22/1999	STRUCTURE AND METHOD FOR A MICROELECTROMECHANICALLY TUNABLE FABRY-PEROT CAVITY SPECTROPHOTOMETER	KUBBY, JOEL A.
09468423	6362512	150	12/21/1999	MICROELECTROMECHANICAL STRUCTURES DEFINED FROM SILICON ON INSULATOR WAFERS	KUBBY, JOEL A.
09468141	6379989	150	12/21/1999	PROCESS FOR MANUFACTURE OF MICROOPTOMECHANICAL STRUCTURES	KUBBY, JOEL A.
09467526	Not Issued	161	12/21/1999	SILICON ON INSULATOR SURFACE MICROMACHINING PROCESS	KUBBY, JOEL A.
09448774	Not Issued	160	11/24/1999	SPECTROPHOTOMETER FOR COLOR PRINTER COLOR CONTROL WITH DISPLACEMENT	KUBBY, JOEL A.

				INSENSITIVE OPTICS	
<u>09416329</u>	<u>6357865</u>	150	10/12/1999	MICRO-ELECTRO-MECHANICAL FLUID EJECTOR AND METHOD OF OPERATING SAME	KUBBY, JOEL A.
<u>09415628</u>	Not Issued	161	10/12/1999	METHOD OF FABRICATING A MICRO-ELECTRO-MECHANICAL FLUID EJECTOR	KUBBY, JOEL A.
<u>09326876</u>	<u>6201633</u>	150	06/07/1999	MICRO-ELECTROMECHANICAL BASED BISTABLE COLOR DISPLAY SHEETS	KUBBY, JOEL A.
<u>09232456</u>	<u>6507001</u>	150	01/19/1999	NOZZLES FOR INK JET DEVICES AND LASER ABLATING OR PRECISION INJECTION MOLDING METHODS FOR MICROFABRICATION OF THE NOZZLES	KUBBY, JOEL A.
<u>09210315</u>	<u>6567448</u>	150	12/11/1998	SCANNING III-V COMPOUND LIGHT EMITTERS INTEGRATED WITH SI-BASED ACTUATORS	KUBBY, JOEL A.
<u>09209866</u>	<u>6054335</u>	150	12/11/1998	FABRICATION OF SCANNING III-V COMPOUND LIGHT EMITTERS INTEGRATED WITH SI-BASED ACTUATORS	KUBBY, JOEL A.
<u>09203442</u>	<u>6014240</u>	150	12/01/1998	METHOD AND APPARATUS FOR AN INTEGRATED LASER BEAM SCANNER USING A CARRIER SUBSTRATE	KUBBY, JOEL A.
<u>09201738</u>	<u>6002507</u>	150	12/01/1998	METHOD AND APPARTUS FOR AN INTEGRATED LASER BEAM SCANNER	KUBBY, JOEL A.
<u>09200353</u>	<u>6177800</u>	150	11/10/1998	METHOD AND APPARATUS FOR USING SHUTTERED WINDOWS IN A MICRO-ELECTRO-MECHANICAL SYSTEM	KUBBY, JOEL A.
<u>09196396</u>	<u>6121983</u>	150	11/19/1998	METHOD AND APPARATUS FOR A SOLID STATE LASER SCANNING ARCHITECTURE	KUBBY, JOEL A.
<u>09173329</u>	<u>6116756</u>	150	10/15/1998	MONOLITHIC SCANNING LIGHT EMITTING DEVICES	KUBBY, JOEL A.
<u>09172883</u>	<u>6180428</u>	150	10/15/1998	MONOLITHIC SCANNING LIGHT EMITTING DEVICES USING MICROMACHINING	KUBBY, JOEL A.
<u>09164250</u>	<u>6340216</u>	150	09/30/1998	BALLISTIC AERSOL MARKING APPARATUS FOR TREATING A SUBSTRATE	KUBBY, JOEL A.

<u>09164124</u>	<u>6416157</u>	150	09/30/1998	METHOD OF MARKING A SUBSTRATE EMPLOYING A BALLISTIC AEROSOL MARKING APPARATUS	KUBBY, JOEL A.
<u>09163954</u>	<u>6328409</u>	150	09/30/1998	BALLISTIC AEROSOL MARKING APPARATUS FOR MARKING WITH A LIQUID MATERIAL	KUBBY, JOEL A.
<u>09163924</u>	<u>6454384</u>	150	09/30/1998	METHOD FOR MARKING WITH A LIQUID MATERIAL USING A BALLISTIC AEROSOL MARKING APPARATUS	KUBBY, JOEL A.
<u>09163893</u>	<u>6511149</u>	150	09/30/1998	BALLISTIC AEROSOL MARKING APPARATUS FOR MARKING A SUBSTRATE	KUBBY, JOEL A.
<u>09163839</u>	<u>6290342</u>	150	09/30/1998	MARKING MATERIAL TRANSPORT	KUBBY, JOEL A.
<u>09163808</u>	<u>6523928</u>	150	09/30/1998	METHOD OF TREATING A SUBSTRATE EMPLOYING A BALLISTIC AEROSOL MARKING APPARATUS	KUBBY, JOEL A.
<u>09163765</u>	<u>6467862</u>	150	09/30/1998	CARTRIDGE FOR USE IN A BALLISTIC AEROSOL MARKING APPARATUS	KUBBY, JOEL A.
<u>09069698</u>	<u>6293668</u>	150	04/29/1998	METHOD AND APPARATUS FOR TREATING RECORDING MEDIA TO ENHANCE PRINT QUALITY IN AN INK JET PRINTER	KUBBY, JOEL A.
<u>09032923</u>	<u>6100909</u>	150	03/02/1998	MATRIX ADDRESSABLE ARRAY FOR DIGITAL XEROGRAPHY	KUBBY, JOEL A.
<u>08929599</u>	<u>5851412</u>	150	09/15/1997	THERMAL INK-JET PRINthead WITH A SUSPENDED HEATING ELEMENT IN EACH EJECTOR	KUBBY, JOEL A.
<u>08869946</u>	<u>6234608</u>	150	06/05/1997	MAGNETICALLY ACTUATED INK JET PRINTING DEVICE	KUBBY, JOEL A.
<u>08811987</u>	<u>5744732</u>	150	03/05/1997	SHEET MATERIALS TRANSPORT SYSTEM	KUBBY, JOEL A.
<u>08761681</u>	Not Issued	161	12/06/1996	RASTER OUTPUT SCANNER WITH PIVOTAL MIRROR FOR PROCESS DIRECTION LIGHT SPOT POSITION CONTROL	KUBBY, JOEL A.
<u>08754420</u>	Not Issued	161	11/22/1996	DISTRIBUTABLE VIBRATION SENSORS FOR PRINTER DIAGNOSTICS	KUBBY, JOEL A.
<u>08741422</u>	<u>5971527</u>	150	10/29/1996	INK JET CHANNEL WAFER FOR A THERMAL INK JET PRINthead	KUBBY, JOEL A.

08721515	6007173	150	09/26/1996	INK STATUS SYSTEM FOR A LIQUID INK PRINTER	KUBBY, JOEL A.
08670117	5637189	150	06/25/1996	DRY ETCH PROCESS CONTROL USING ELECTRICALLY BIASED STOP JUNCTIONS	KUBBY, JOEL A.
08670042	5865938	150	06/25/1996	WAFER CHUCK FOR INDUCING AN ELECTRICAL BIAS ACROSS WAFER HETEROJUNCTIONS	KUBBY, JOEL A.
08666940	5714697	150	06/19/1996	SHEET MATERIALS MASS MEASURING SYSTEM	KUBBY, JOEL A.
08666765	5835975	150	06/19/1996	PAPER PROPERTY SENSING SYSTEM	KUBBY, JOEL A.
08632293	5751317	150	04/15/1996	THERMAL INK-JET PRINthead WITH AN OPTIMIZED FLUID FLOW CHANNEL IN EACH EJECTOR	KUBBY, JOEL A.
08609198	5706041	150	03/04/1996	THERMAL INK-JET PRINthead WITH A SUSPENDED HEATING ELEMENT IN EACH EJECTOR	KUBBY, JOEL A.
08570299	5721574	150	12/11/1995	INK DETECTING MECHANISM FOR A LIQUID INK PRINTER	KUBBY, JOEL A.
08248047	5487483	150	05/24/1994	NOZZLES FOR INK JET DEVICES AND METHOD FOR MICROFABRICATION OF THE NOZZLES	KUBBY, JOEL A.

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Application#	Patent#	Status	Date Filed	Title	Inventor Name 44
60637205	Not Issued	020	12/17/2004	HYDROPHILICALLY MODIFIED POLYOLS FOR IMPROVED HYDROPHOBIC SOIL CLEANING	MA, JUN
60637204	Not Issued	020	12/17/2004	HYDROPHOBICALLY MODIFIED POLYOLS FOR IMPROVED HYDROPHOBIC SOIL CLEANING	MA, JUN
60630946	Not Issued	020	11/24/2004	METHOD FOR PREPARING SINGLE WALLED CARBON NANOTUBES	MA, JUN
60628678	Not Issued	020	11/17/2004	METHOD FOR PREPARING SUPPORTED CATALYSTS FROM SINGLE WALLED CARBON NANOTUBES	MA, JUN
60628498	Not Issued	020	11/16/2004	METHOD FOR PREPARING SINGLE WALLED CARBON NANOTUBES	MA, JUN
60628469	Not Issued	020	11/16/2004	METHOD FOR PREPARING SUPPORTED CATALYSTS VIA EXTRUSION OF METAL LOADED CARBON NANOTUBES	MA, JUN
60621132	Not Issued	020	10/22/2004	OZONOLYSIS OF CARBON NANOTUBES	MA, JUN
60493198	Not Issued	159	08/07/2003	SIGNAL ESTIMATION METHOD AND DEVICE WITH APPLICATION TO HELICOPTER DYNAMIC LOADS	MA, JUN
60388616	Not Issued	159	06/14/2002	ELECTROCONDUCTIVE CARBON FIBRIL-BASED INKS AND COATINGS	MA, JUN
11010768	Not Issued	041	12/13/2004	METHODOLOGY FOR A MEMS VARIABLE OPTICAL ATTENUATOR	MA, JUN

<u>11004790</u>	Not Issued	030	12/03/2004	EXTERNAL COUNTER PULSATION APPARATUS	MA, JUN
<u>10940242</u>	Not Issued	020	09/14/2004	METHOD OF USING CARBIDE AND/OR OXYCARBIDE CONTAINING COMPOSITIONS	MA, JUN
<u>10914531</u>	Not Issued	020	08/09/2004	MICROMECHANICAL DISPENSING DEVICE AND A DISPENSING SYSTEM INCLUDING THE SAME	MA, JUN
<u>10879094</u>	Not Issued	020	06/30/2004	OPTICAL SHUTTLE SYSTEM AND METHOD USED IN AN OPTICAL SWITCH	MA, JUN
<u>10873739</u>	Not Issued	020	06/22/2004	MODIFIED CARBIDE AND OXYCARBIDE CONTAINING CATALYSTS AND METHODS OF MAKING AND USING THEREOF	MA, JUN
<u>10828411</u>	Not Issued	020	04/20/2004	VIDEO GAME SYSTEM INCLUDING A MICROMECHANICAL DISPENSING DEVICE	MA, JUN
<u>10827922</u>	Not Issued	020	04/20/2004	ENVIRONMENTAL SYSTEM INCLUDING A MICROMECHANICAL DISPENSING DEVICE	MA, JUN
<u>10810930</u>	Not Issued	041	03/26/2004	CONTROLLED STARTING AND BRAKING OF AN INTERNAL COMBUSTION ENGINE	MA, JUN
<u>10810538</u>	Not Issued	041	03/26/2004	ELECTROMAGNETIC ACTUATOR AND CONTROL	MA, JUN
<u>10772693</u>	Not Issued	071	02/05/2004	THERMAL ACTUATOR WITH OFFSET BEAM SEGMENT NEUTRAL AXES AND AN OPTICAL WAVEGUIDE SWITCH INCLUDING THE SAME	MA, JUN
<u>10772564</u>	Not Issued	071	02/05/2004	THERMAL ACTUATOR AND AN OPTICAL WAVEGUIDE SWITCH INCLUDING THE SAME	MA, JUN
<u>10732724</u>	Not Issued	020	12/10/2003	DEVICE AND SYSTEM FOR DISPENSING FLUIDS INTO THE ATMOSPHERE	MA, JUN
<u>10727191</u>	Not Issued	041	12/03/2003	BISTABLE MICROELECTROMECHANICAL SYSTEM BASED STRUCTURES, SYSTEMS AND METHODS	MA, JUN
<u>10712200</u>	Not Issued	041	11/12/2003	MEMS WAVEGUIDE SHUTTLE OPTICAL LATCHING SWITCH	MA, JUN

<u>10634941</u>	Not Issued	071	08/05/2003	THERMAL ACTUATOR AND AN OPTICAL WAVEGUIDE SWITCH INCLUDING THE SAME	MA, JUN
<u>10620023</u>	Not Issued	030	07/14/2003	REVERSE RATE INDICATOR DETECTION	MA, JUN
<u>10517748</u>	Not Issued	019	01/01/0001	ELECTROCONDUCTIVE CARBON FIBRIL-BASED INKS AND COATINGS	MA, JUN
<u>10490514</u>	Not Issued	019	01/01/0001	EXTERNAL COUNTER PULSATION APPARATUS	MA, JUN
<u>10487107</u>	Not Issued	030	02/17/2004	POWER SUPPLY SYSTEM AND APPARATUS	MA, JUN
<u>10456148</u>	Not Issued	020	06/06/2003	METHOD AND APPARATUS FOR NEAR-OPTIMAL SCALING OF LOG-LIKELIHOOD RATIO (LLR) COMPUTATION IN TURBO DECODING FOR HYBRID AUTOMATIC REPEAT REQUEST (ARQ)	MA, JUN
<u>10305338</u>	Not Issued	030	11/26/2002	REVERSE LINK AUTOMATIC REPEAT REQUEST	MA, JUN
<u>10280740</u>	Not Issued	030	10/24/2002	REVERSE LINK AUTOMATIC REPEAT REQUEST	MA, JUN
<u>10170269</u>	6841508	150	06/11/2002	CARBIDE AND OXYCARBIDE BASED COMPOSITIONS, RIGID POROUS STRUCTURES INCLUDING THE SAME, METHODS OF MAKING AND USING THE SAME	MA, JUN
<u>10150370</u>	Not Issued	071	05/17/2002	MODIFICATION OF NANOTUBES OXIDATION WITH PEROXYGEN COMPOUNDS	MA, JUN
<u>10063762</u>	6828887	150	05/10/2002	BISTABLE MICROELECTROMECHANICAL SYSTEM BASED STRUCTURES, SYSTEMS AND METHODS	MA, JUN
<u>10023618</u>	6809229	150	12/18/2001	METHOD OF USING CARBIDE AND/OR OXYCARBIDE CONTAINING COMPOSITIONS	MA, JUN
<u>09861370</u>	6872681	150	05/18/2001	MODIFICATION OF NANOTUBES OXIDATION WITH PEROXYGEN COMPOUNDS	MA, JUN
<u>09772742</u>	6660713	150	01/30/2001	HYDROPHOBIC NANOZEOLITES FOR MALODOR CONTROL	MA, JUN
<u>09615350</u>	Not	161	07/12/2000	CARBIDE AND OXYCARBIDE	MA, JUN

	Issued			BASED COMPOSITIONS, RIGID POROUS STRUCTURES INCLUDING THE SAME, METHODS OF MAKING AND USING THE SAME	
<u>09481184</u>	<u>6514897</u>	150	01/12/2000	CARBIDE AND OXYCARBIDE BASED COMPOSITIONS, RIGID POROUS STRUCTURES INCLUDING THE SAME, METHODS OF MAKING AND USING THE SAME	MA, JUN
<u>08832512</u>	<u>5939753</u>	150	04/02/1997	MONOLITHIC RF MIXED SIGNAL IC WITH POWER AMPLIFICATION	MA, JUN
<u>08812175</u>	<u>5908748</u>	250	03/06/1997	SPECIES-SPECIFIC YEAST TFIIB SEQUENCE	MA, JUN
<u>08507898</u>	<u>5656844</u>	150	07/27/1995	SEMICONDUCTOR-ON- INSULATOR TRANSISTOR HAVING A DOPING PROFILE FOR FULLY-DEPLETED OPERATION	MA, JUN

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Application#	Patent#	Status	Date Filed	Title	Inventor Name 26
60478749	Not Issued	159	06/16/2003	UNIVERSAL FLEXIBLE PLURAL PRINTER TO PLURAL FINISHER SHEET INTEGRATION SYSTEM	GERMAN, KRISTINE A.
60476374	Not Issued	159	06/06/2003	UNIVERSAL FLEXIBLE PLURAL PRINTER TO PLURAL FINISHER SHEET INTEGRATION SYSTEM	GERMAN, KRISTINE A.
60456087	Not Issued	159	03/19/2003	MEMS WAVEGUIDE SHUTTLE OPTICAL LATCHING SWITCH	GERMAN, KRISTINE A.
60456063	Not Issued	159	03/19/2003	MEMS OPTICAL LATCHING SWITCH	GERMAN, KRISTINE A.
11069020	Not Issued	020	02/28/2005	PRINTING SYSTEMS	GERMAN, KRISTINE A.
11010769	Not Issued	030	12/13/2004	CANTILEVER BEAM MEMS VARIABLE OPTICAL ATTENUATOR	GERMAN, KRISTINE A.
11000168	Not Issued	030	11/30/2004	ADDRESSABLE FUSING AND HEATING METHODS AND APPARATUS	GERMAN, KRISTINE A.
10999450	Not Issued	030	11/30/2004	ADDRESSABLE FUSING FOR AN INTEGRATED PRINTING SYSTEM	GERMAN, KRISTINE A.
10924458	Not Issued	020	08/23/2004	PRINT SEQUENCE SCHEDULING FOR RELIABILITY	GERMAN, KRISTINE A.
10918093	Not Issued	030	08/13/2004	BEAM SWITCH STRUCTURES AND METHODS	GERMAN, KRISTINE A.
10917676	Not Issued	030	08/13/2004	MULTIPLE OBJECT SOURCES CONTROLLED AND/OR SELECTED BASED ON A COMMON SENSOR	GERMAN, KRISTINE A.
10878834	Not Issued	030	06/28/2004	WAVEGUIDE STRUCTURES AND METHODS	GERMAN, KRISTINE A.

<u>10860195</u>	Not Issued	030	06/03/2004	UNIVERSAL FLEXIBLE PLURAL PRINTER TO PLURAL FINISHER SHEET INTEGRATION SYSTEM	GERMAN, KRISTINE A.
<u>10785211</u>	Not Issued	030	02/24/2004	UNIVERSAL FLEXIBLE PLURAL PRINTER TO PLURAL FINISHER SHEET INTEGRATION SYSTEM	GERMAN, KRISTINE A.
<u>10772693</u>	Not Issued	071	02/05/2004	THERMAL ACTUATOR WITH OFFSET BEAM SEGMENT NEUTRAL AXES AND AN OPTICAL WAVEGUIDE SWITCH INCLUDING THE SAME	GERMAN, KRISTINE A.
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Application#	Patent#	Status	Date Filed	Title	Inventor Name 29
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<u>60456063</u>	Not Issued	159	03/19/2003	MEMS OPTICAL LATCHING SWITCH	GULVIN, PETER M.
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